



HICKMAN PALERMO TRUONG & BECKER LLP (408) 414-1080, Ext. 203
Title: Treatment System for Removing Hazardous Substances from a Semiconductor
Process Waste Gas Stream
Inventors: Christopher Hertzler, et al.; Serial No.: 09/846,495; Docket No: 60040-0015
Replacement Sheet

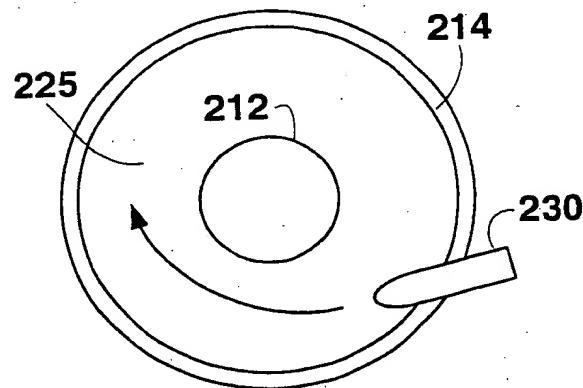


FIG. 2B

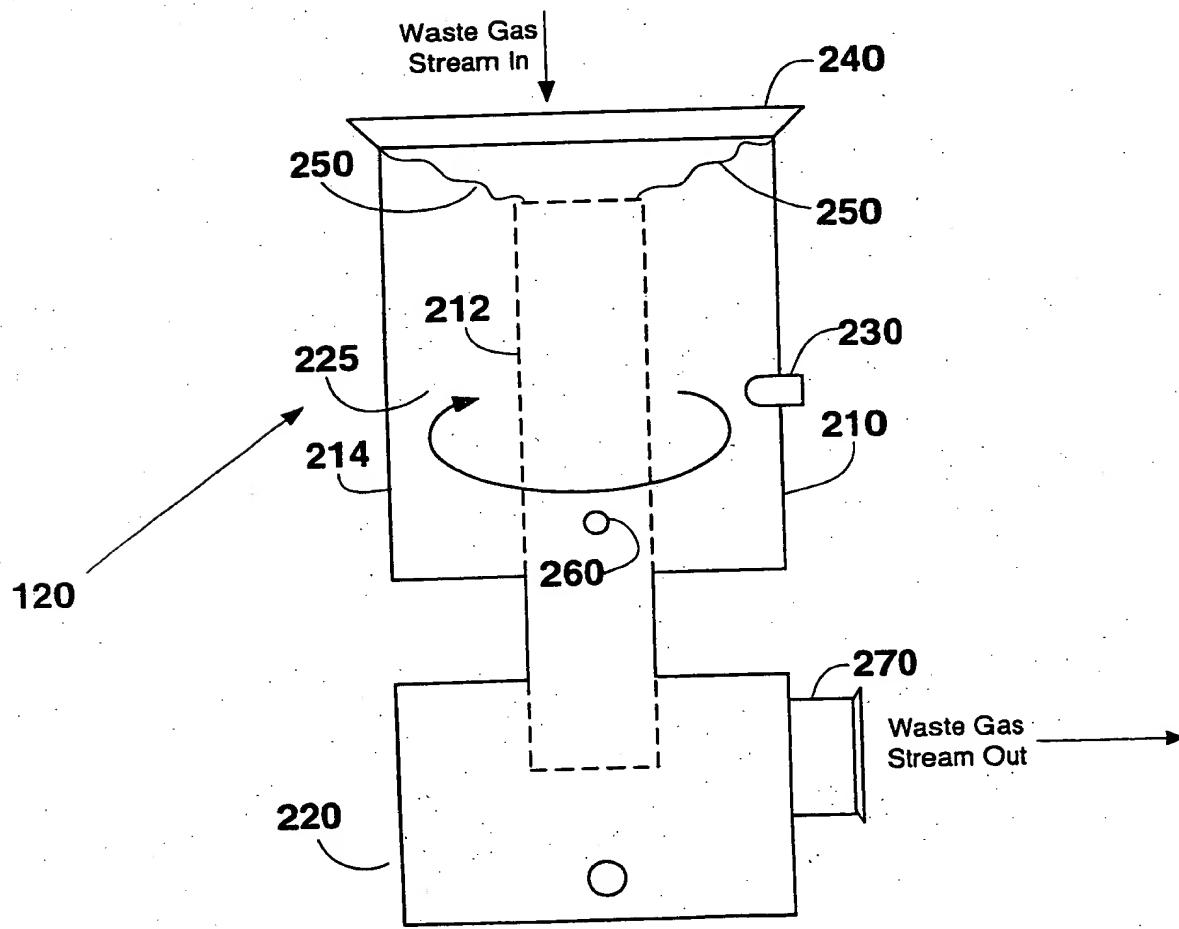


FIG. 2A